



差压和表压补偿式压力传感器（0至**10**千帕）

MPXx2010

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恩智浦的MPX2010/MPXV2010G/MPXM2010系列压阻式硅压力传感器，可提供精确线性电压输出，与施加压力成正比。

- 通过激光调校实现精确的量程和偏移量校准以及温度补偿
- 该系列传感器在每个芯片上集成了应变片和薄膜电阻网络

MPXX2010_BD Block Diagram

PACKAGING ORDERING INFORMATION		
Device Type	Packing Options	Case
MPX2010D	Differential	344
MPX2010DP	Differential, Dual Port	344C
MPX2010GP	Gauge	344B
MPX2010GS	Gauge, Axial	344E
MPX2010GSX	Gauge, Axial PC Mount	344F
MPXM2010D	Non-ported	1320
MPXM2010DT1	Non-ported, Tape and Reel	1320
MPXM2010GS	Ported	1320A
MPXM2010GST1	Ported, Tape and Reel	1320A
MPXV2010GP	Gauge, Side Port, SMT	1369
MPXV2010DP	Differential, Dual Port, SMT	1351

View additional information for [差压和表压补偿式压力传感器（0至10千帕）](#).

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